

IRLabs

A SUBSIDIARY OF INFRARED LABORATORIES, INC.

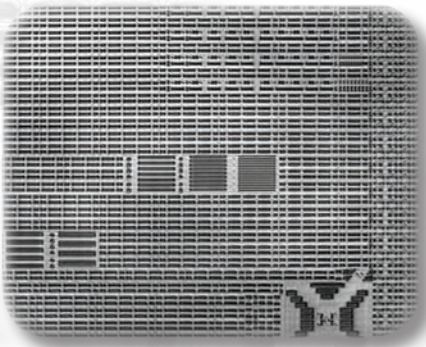
IREM-IV PHOTON EMISSION MICROSCOPE SYSTEM



The newly improved **IREM-IV** system is ready to solve your toughest infrared photon emission FA problems. For over 20 years, IRLabs has worked with the world's leading semiconductor companies to provide the most sensitive photon emission FA tools. **Learn more about how IRLabs can provide a customized solution for you...**

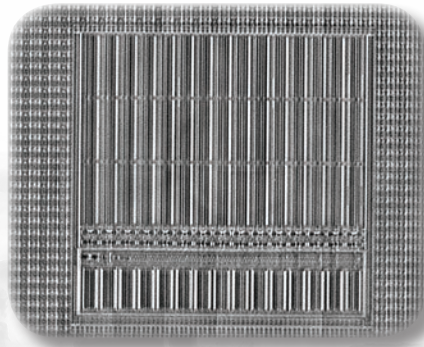
HIGHEST RESOLUTION

Debug 10 nm Process



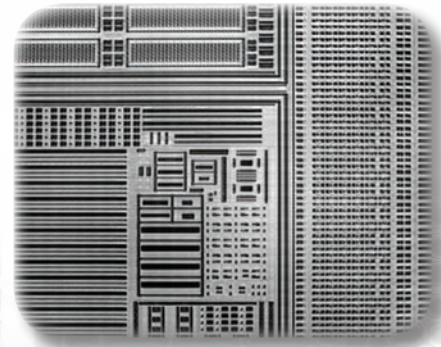
MOST SENSITIVE

Image 400 mV Emissions



LARGEST FIELD OF VIEW

Custom Optics



IREM-IV

ULTRA-LOW NOISE MCT (HgCdTe) CAMERA

The IREM-IV camera provides ultra-low noise extended wavelength PEM imaging, with proven emission imaging sensitivity on 10 nm devices operating at 400 mV. We design and build our own cameras for low-maintenance operation with superior features including a 6-position lens turret and LN2 hold time longer than 20 hours. An optical expansion port provides an upgrade path for external laser scanning OBIRCH, LADA, TIVA, and other imaging modes

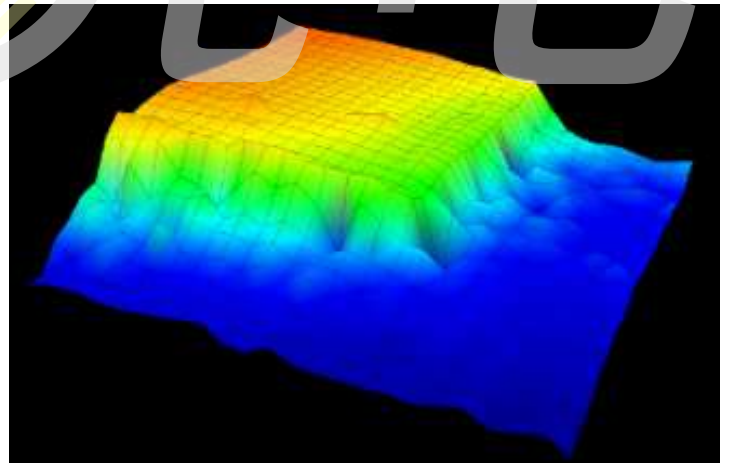


SIL 3.3 NA OBJECTIVE

The 3.3NA SIL objective is the latest in our family of custom designed lenses optimized to provide superior, diffraction-limited imaging over the entire field-of-view. Our patented self-aligning SIL tip automatically levels to conform to the local contour of the device under test. Our unique tip flexure design provides the lowest contact force in the industry, so it is suitable for imaging mounted devices or bare wafers. Contact IRLabs to arrange a demonstration using your device or wafer.

SURFACE PROFILE SENSOR

The integrated profile sensor measures device surface contour with height resolution better than 10 μm . Localized surface tilting from turned-down edges or device bowing can be directly measured and compensated using the tip-tilt table integrated with our precision x-y-z camera stage. When combined with our self-aligning SIL tip, the result is trouble-free SIL imaging.



DUAL COOLED FILTER/APERTURE WHEELS

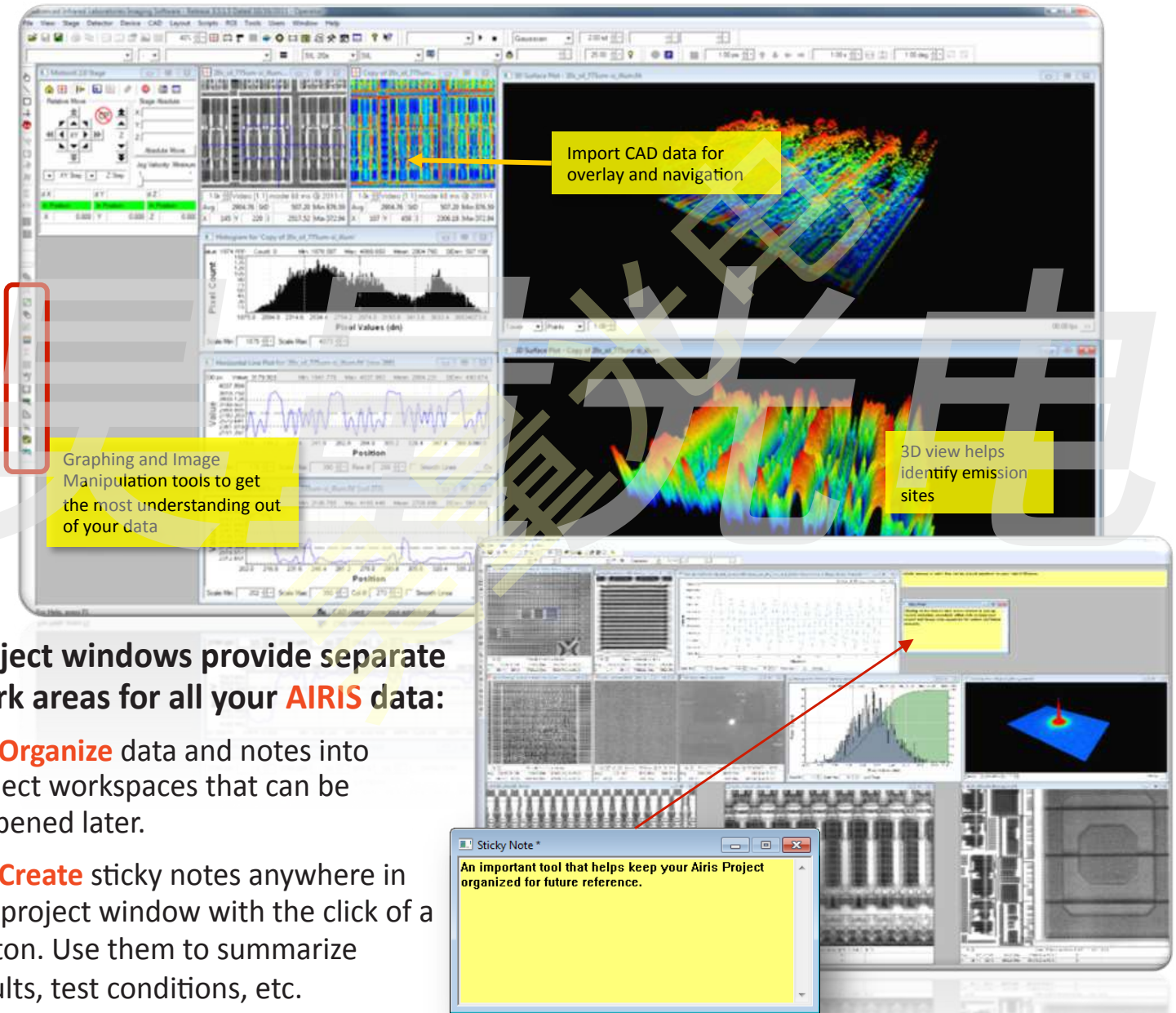
Extended wavelength PEM imaging is typically thermal background noise-limited. IREM-IV provides two internal cooled filter wheels so the optimum spectral filter or background limiting aperture is always available for any measurement scenario.

AIRIS Software

EASE OF USE – MAXIMIZED THROUGHPUT

Controlling the **IREM** system is easy with AIRIS software which also provides comprehensive image analysis and test project management tools:

- Navigate to any point on your sample by clicking on any open image
- Point database for rapid return to multiple points of interest
- Create large field-of-view, high resolution mosaic images
- Automate measurement tasks with **AIRIS** scripting



Project windows provide separate work areas for all your **AIRIS** data:

- **Organize** data and notes into project workspaces that can be reopened later.
- **Create** sticky notes anywhere in the project window with the click of a button. Use them to summarize results, test conditions, etc.

CUSTOMER SERVICE PARTNERSHIP

IRLabs works with customers to create customized solutions for their unique FA requirements. We offer comprehensive service and support plans to ensure maximum uptime and quality for your operations, including worldwide onsite service, preventative maintenance, training, and online or telephone technical support.

IREM-IV SYSTEM

SPECIFICATIONS

IREM-IV Camera

- 1016 x 1016px LN2-Cooled MCT Array
- 18 micron pixel size
- 440 - 2500nm Spectral Range
- 6 Position Motorized Lens Turret
- 6 Position Dual Internal Cooled Filter/Aperture Wheels
- >20 Hour LN2 Hold time

System Dimensions

Microscope

- 810mm x 876mm x 813mm
- 160kg

Electronics Rack

- 610mm x 1283mm x 762mm
- 90kg

Motion System

- 25nm Resolution
- 100mm Range (x-y-z)
- Damped Vibration Isolation
- Motorized Sample Tip-Tilt Option

System Features

- Inverted Microscope Design
Allows docking with all common testers
- Optional Wafer Probing Capability
- Optional Laser Sensor
Measures DUT surface tilt/profile
- Modular Upgrade Path/Optical Expansion Port
Suitable for intergating external laser scanner or other optical systems (Contact IRLabs)

AIRIS Software

Intuitive User Friendly Software with CAD Overlay, powerful image processing tools and project manager.

Available Lenses

Magnification	1x	10x	20x	20x	20x	50x	100x	380x	380x
NA	0.05	0.26	0.50	0.60	0.40	0.70	0.70	3.0	3.3
Working Distance	35.0mm	30.5mm	12.0mm	10.0mm	20.0mm	10.0mm	10.0mm	SIL	SIL
Field of View	18.432mm x 18.432mm	18.432mm x 18.432mm	0.922mm x 0.922mm	0.922mm x 0.922mm	0.922mm x 0.922mm	0.370mm x 0.370mm	0.184mm x 0.184mm	0.050mm x 0.050mm	0.050mm x 0.050mm